Application/Control No. Applicant(s)/Patent Under Reexamination 10/649,738 CHOI ET AL. Notice of References Cited Art Unit Examiner Page 1 of 1 2871 Mike Qi **U.S. PATENT DOCUMENTS** Date **Document Number** Classification Name Country Code-Number-Kind Code MM-YYYY 349/139 12-1998 Takatori, Ken-ichi US-5,844,652 A Α Takatori, Kenichi 349/172 US-6,351,301 B1 02-2002 В 428/1.1 С US-6,436,490 B1 08-2002 Nishimura et al. US-D US-Ε US-F US-G USн US-US-J Κ US-US-L US-М FOREIGN PATENT DOCUMENTS Document Number Date Classification Name Country Country Code-Number-Kind Code MM-YYYY N 0 Р Q R S Т **NON-PATENT DOCUMENTS** Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages) U W

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